

Docket No.: 1592-0163PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

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Art Unit: 2895

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

RESPONSE SUBMITTED UNDER 37 C.F.R. § 1.114

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.